Satoshi YAMAMOTO, et al.
METHOD OF FORMING A PENETRATION
ELECTRODE AND SUBSTRATE HAVING A...
U.S. Application No. 10/736,581
SUGHRUE MION, PLLC: 202.293.7060
Replacement Sheet 1 of 1





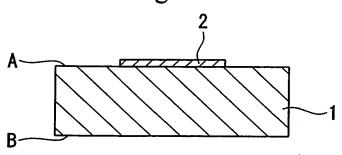


Fig. 1B PRIOR ART

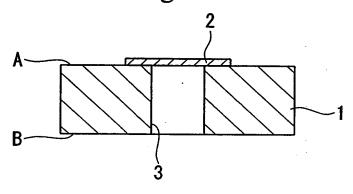


Fig. 1C PRIOR ART

